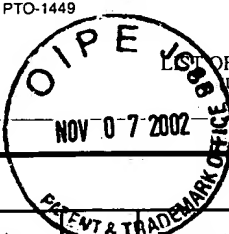


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826	
<div style="text-align: center;">  </div>				APPLICANT Weimin (Michael) Li et al.			
				FILING DATE September 1, 1999		GROUP 2813	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
EK ↑	AA	6,184,158 B1	02/01	Shufflebotham et al.	/	/	
	AB	6,096,656	08/00	Matzke et al.	/	/	
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FOREIGN PATENT DOCUMENTS							
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						Yes	No
EK ↑	AK	EP 1 172 845 A2	01/02	EP	/	/	
	AL	JP 08-213386 A	08/96	JP	/	/	
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	↓ EK	AQ	TW 420844 A	02/01	TW	/	/
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
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EK	AA	4,562,091	12/31/85	Sachdev et al.			
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EK	AI	5,986,318	11/16/99	Kim et al.			
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							Yes	No
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